	Application No.	Applicant(s)	(in
Notice of Allowability	10/664,903	FINK, STEVEN T.	\$co
	Examiner	Art Unit	
	Thuy V. Tran	2821	
	Thuy v. Tran	2021	
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in) or other appropriate communication is sufficient in sufficiency.	this application. If not included nication will be mailed in due cours	se. THIS
1. \boxtimes This communication is responsive to <u>amendment after fine</u>	al 02/02/2006.		
2. X The allowed claim(s) is/are 1-14,16-20,22 and 23.			
3. Acknowledgment is made of a claim for foreign priority u	nder 35 U.S.C. § 119(a)-(d) o	r (f).	
a) ☐ All b) ☐ Some* c) ☐ None of the:			
1. Certified copies of the priority documents have	e been received.		
2. Certified copies of the priority documents have	e been received in Applicatior	n No	
3. Copies of the certified copies of the priority do	ocuments have been received	in this national stage application f	rom the
International Bureau (PCT Rule 17.2(a)).			
* Certified copies not received:			
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		a reply complying with the requirer	ments
4. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which giv			E OF
5. CORRECTED DRAWINGS (as "replacement sheets") mu	st be submitted.		
(a) including changes required by the Notice of Draftsper	son's Patent Drawing Review	(PTO-948) attached	
1) hereto or 2) to Paper No./Mail Date	<u>.</u> .		
(b) including changes required by the attached Examiner Paper No./Mail Date	's Amendment / Comment or i	n the Office action of	
Identifying indicia such as the application number (see 37 CFR feach sheet. Replacement sheet(s) should be labeled as such in			i) of
 DEPOSIT OF and/or INFORMATION about the depo- attached Examiner's comment regarding REQUIREMENT 			the
Attachment(s)	E □ Notice of Infe	ormal Patent Application (PTO-152) \
 Notice of References Cited (PTO-892) Notice of Draftperson's Patent Drawing Review (PTO-948) 	6. 🔲 Interview Su	mmary (PTO-413),	-)
3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/	Paper No./N 08), 7. ☐ Examiner's A	Mail Date Amendment/Comment	
Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. ⊠ Examiner's S	Statement of Reasons for Allowand	ce /
		THUY V.TRAN PRIMARY EXAMINER	

Application/Control Number: 10/664,903 Page 2

Art Unit: 2821

DETAILED ACTION

This is a response to the Applicant's amendment after final under 37 CFR 1.116. In virtue of this amendment, claims 15 and 21 are canceled, and thus, claims 1-14, 16-20, and 22-23 are now presented in the instant application.

Allowable Subject Matter

1. Claims 1-14, 16-20, and 22-23 are allowed.

Reasons for Allowance

2. The following is an examiner's statement of reasons for allowance:

Prior art fails to disclose or fairly suggest:

- An assembly configured to be coupled to components of a plasma reactor, the
 assembly comprising at least one spira-shield electrically connected to the
 electrostatic shield, in combination with the remaining claimed limitations as called
 for in independent claim 1 (claims 6 and 22 are allowed since they are dependent on
 claim 1);
- An assembly configured to be coupled to components of a plasma reactor, the
 assembly comprising at least one spira-shield electrically coupled to the electrostatic
 shield, in combination with the remaining claimed limitations as called for in
 independent claims 2, 10, 11, and 14 (claims 12, 16, and 23 are allowed since they are
 dependent on claim 11);
- An assembly configured to be coupled to components of a plasma reactor, the
 assembly comprising at least one insulating spacer located between the electrostatic
 shield and an end of the process tube, in combination with the remaining claimed

limitations as called for in independent claim 3 (claims 4-5 are allowed since they are dependent on claim 3);

- An assembly configured to be coupled to components of a plasma reactor; the
 assembly comprising an electrostatic shield patterned directly on the process tube, in
 combination with the remaining claimed limitations as called for in independent
 claim 7 (claims 8-9 are allowed since they are dependent on claim 7);
- An assembly configured to be coupled to components of a plasma reactor wherein the
 electrostatic shield is implemented between two sheets of the flex-print material
 except on a top and bottom to allow for contacts with a spira-shield, in combination
 with the remaining claimed limitations as called for in independent claim 13;
- A method of fabricating an assembly including a housing, a process tube, and an
 electrostatic shield comprising electrically coupling the electrostatic shield to the
 housing through a spira-shield, in combination with the remaining claimed limitations
 as called for in independent claim 17;
- A method of fabricating an assembly including both a process tube and an
 electrostatic shield, the method comprising patterning the electrostatic shield onto the
 process tube using at least one of sputtering, evaporation or metal vapor deposition, in
 combination with the remaining claimed limitations as called for in independent
 claim 18 (claim 19 is allowed since it is dependent on claim 18); and
- A method of fabricating an assembly including both a process tube and an
 electrostatic shield, the method comprising electrically coupling the electrostatic

Art Unit: 2821

shield to at least one spira-shield, in combination with the remaining claimed limitations as called for in independent claim 20.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Inquiry

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Thuy V. Tran whose telephone number is (571) 272-1828. The examiner can normally be reached on M-F (8:00 AM -5:00 PM).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Don Wong can be reached on (571) 272-1834. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

02/10/2006

THUYV.TRAN
PRIMARY FXAMINER